

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Junko Yotani et al.

Application No.: 10/824,310

Filed: April 13, 2004

For: **METHOD OF MANUFACTURING
ELECTRON-EMITTING SOURCE**

Examiner: Stouffer, Kelly M.

Art Unit: 1762

Confirmation No.: 5984

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

AMENDMENT AND RESPONSE TO OFFICE ACTION

In response to the Office Action mailed December 4, 2007, in connection with the above referenced patent application, Applicants respectfully request entry of the following amendments and request reconsideration in view of the following remarks.